

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

In re application of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL MECHANICAL POLISHING APPARATUS AND METHOD TO
MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 3723

Examiner Shantese L. McDonald

Customer No. 23494

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450,, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

2-21-00

Jay M. Cantor, Reg. No. 19,906

NOTICE OF APPEAL

Sir:

Applicant hereby appeals to the Board of Appeals from the decision dated January 25, 2006 of the Primary Examiner finally rejecting claims 1, 2, 4 to 8 and 10 to 15, all of the rejected claims.

The item(s) checked below are appropriate:

1. ☐ An extension of time to respond to the final rejection
☐ was granted on
☐ is requested for _____ month(s).
2. ☐ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.
3. ☒ Fee \$500.00:
☐ Not required (*Fee paid in prior appeal*)
☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Account No. 20-0668. A duplicate copy of this sheet is enclosed.

Signature [Rule 191(b)]

Post Office Address

(to which correspondence is to be sent)

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On the date stamped here, the following paper was
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Notice of Appeal

Inventor(s): Michael Shu-Huan Wang et al.
Serial No 10/718,921
Filed November 21, 2003
For: Chemical-Mechanical Polishing Apparatus...
Docket Number: TI-34402

